

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 7872

Tatsuki NOGIWA et al.

Attorney Docket No. 2004 0601A

Serial No. 10/825,335

Group Art Unit 1734

Filed April 16, 2004

Examiner George R. Koch

SUBSTRATE SUPPORT JIG, CIRCUIT BOARD PRODUCTION APPARATUS, AND METHOD OF PRODUCING Mail Stop: RCE

CIRCUIT BOARD

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of April 19, 2007, and further to the Request for Continued Examination (RCE) filed concurrently herewith, please amend the above-referenced U.S. patent application as follows: